

NIP-155-02

Prior Application: M. NAGASE et al
Serial No. 09/405,217
Filed: September 27, 1999

Group Art Unit: 1754
Examiner: E. Nave
For: METHOD OF CHEMICAL DECONTAMINATION
AND SYSTEM THEREFOR

December 4, 2001

This is a request for filing a divisional application under 37 CFR §1.53(b) of pending prior application Serial No. 09/405,217, filed on September 27, 1999, entitled METHOD OF CHEMICAL DECONTAMINATION AND SYSTEM THEREFOR, by all of the inventors named in the prior application.

1. Enclosed is a copy of the prior application, including the Declaration and Statement Under 37 CFR 1.68, DOE/NASA, as originally filed.

2. The Filing Fee is calculated below:

CLAIMS AS FILED IN THE PRIOR APPLICATION
LESS ANY CLAIMS CANCELED BY AMENDMENT BELOW
PLUS ANY CLAIMS ADDED BY ACCOMPANYING PRELIMINARY AMENDMENT

Basic Fee							\$ 740.00
Total Claims	10	-	20	=	0	x 18	= 0.00
Independent Claims	2	-	3	=	0	x 84	= 0.00
Total Filing Fee							\$ 740.00

3. A check including the amount of \$740.00 is enclosed to cover the Filing Fee.

4. The Commissioner is hereby authorized to charge any additional fees which may be required, or to credit any overpayment, to Deposit Account No. 50-1417.

5. New drawings are enclosed, twelve (12) sheets, Figs. 1-10.

6. The power of attorney is set forth in the Declaration in the prior application or an associate power of attorney is hereby granted to:

John R. Mattingly, Registration No. 30,293
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There is a change in the correspondence address.

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Please associate this application with Customer No. 24956.

7. The prior application is assigned to Hitachi, Ltd. and Kurita Engineering Co., Ltd..

8. Priority of the following Japanese patent application is claimed under 35 U.S.C. § 119:

No. 10-274128, filed September 29, 1998.

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STATEMENT (37 CFR 1.68, DOE/NASA)

The undersigned declare:

That I (we) made and conceived the invention described and claimed in patent application: Serial Number 09/405,217, filed in the United States of America on September 27, 1999, titled METHOD OF CHEMICAL DECONTAMINATION AND SYSTEM THEREFOR.

☒ I. (For Inventors Employed by an Organization) That I (we) made and conceived this invention while employed by Hitachi, Ltd. and Kurita Engineering Co., Ltd. That the invention is related to the work I am (we are) employed to perform and was made within the scope of my (our) employment duties; That the invention was made during working hours and with the use of facilities, equipment, materials, funds, information and services of Hitachi, Ltd. and Kurita Engineering Co., Ltd.

That to the best of my (our) knowledge and belief:

☒ II. The invention was not made or conceived in the course of, or in connection with, or under the terms of any contract, subcontract or arrangement entered into with or for the benefit of the United States Atomic Energy Commission (AEC) or its successors; Energy Research and Development Administration (ERDA) or the Department of Energy (DOE).

--AND/OR--

☒ III. The invention was not made (conceived or first actually reduced to practice) under nor is there any relationship of the invention to the performance of any work under any contract of the National Aeronautics and Space Administration (NASA).

--AND/OR--

☒ IV. The invention was not made under contract with the Power Reactor and Nuclear Development Corporation (PNC). Hitachi, Ltd. of Japan is a PNC Cooperator under the Agreement for Cooperation on Technical Development of Fast Breeder Reactors under the Arrangement between USAEC (now ERDA) and PNC of March 4, 1969.

The undersigned inventor(s) declare further that all statements made herein of his or her (their) own knowledge are true and that all statements made on information and belief are believed to be true and further that these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States

Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

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